

Form P-449 <div style="border: 2px solid black; border-radius: 50%; padding: 10px; display: inline-block; transform: rotate(-15deg);"> U.S. DEPT. OF COMMERCE PATENT & TRADEMARK OFFICE JUN 14 2007 </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-878		SERIAL NO. 09/388,857	
OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Luan C. Tran		FILING DATE 09/01/99	
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U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
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						Yes	No
	AL						
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
<div style="font-size: 2em; font-family: cursive;">Ref</div>	AR		S. Wolf, <i>Silicon Processing for the VLSI Era</i> , Volume 3 - The Submicron MOSFET, ©1995 Lattice Press, pages 330, 331, 366 and 367.				
	AS						
	AT						
EXAMINER		DATE CONSIDERED					
<div style="font-size: 1.5em; font-family: cursive;">M. Schuler</div>		<div style="font-size: 1.5em; font-family: cursive;">7/29/07</div>					
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